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2815/4

503.39864X00 / P5829/AM

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Toshiya SATOH et al.
Serial No.: 09/809,181
Filed: 16 March 2001
For: SEMICONDUCTOR DEVICE AND MANUFACTURING
METHOD FOR HIGH RELIABILITY AND PRODUCTION YIELD
RATE WITH MINIMAL DAMAGE DUE TO APPLICATION OF
MECHANICAL STRESS AND THERMAL STRESS
Group: 2815
Examiner: Jose R. Diaz
Conf. No.: 5733

PETITION FOR EXTENSION OF TIME

Mail Stop Amendment

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

16 March 2005

Sir:

Applicant respectfully petitions the Commissioner for an extension of the shortened statutory period for response to the Office Action mailed 16 November 2004 in the above-identified application.. Form PTO-2038 authorizing payment of the requisite Petition fee is submitted concurrently herewith. Please charge any deficiency to ATS&K Deposit Account No. 01-2135 (as 503.39864X00).

Respectfully submitted,

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